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Substitute for form 1449A/B/PTO			<b>Complete if Known</b>		
<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  (Use as many sheets as necessary)			Application Number	Not Yet Assigned	
			Filing Date	September 28, 2004	
			First Named Inventor	Kuniaki Okada	
			Art Unit	N/A	
			Examiner Name	Not Yet Assigned	
Sheet	1	of	1	Attorney Docket Number	62121(70904)

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. <sup>1</sup>	Document Number Number-Kind Code <sup>2</sup> (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
JM	AA	US-5,633,737	05/1997	Tanaka et al.	

FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document Country Code <sup>3</sup> -Number <sup>4</sup> -Kind Code <sup>5</sup> (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T <sup>6</sup>
JM	BA	JP-11-338379	12/1999			✓
JM	BB	JP-2001-341210	12/2001			✓
JM	BC	JP-2001-255660	09/2001			✓
JM	BD	JP-09-090336	04/1997			✓
JM	BE	JP-2000-098102	04/2000			✓

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NON PATENT LITERATURE DOCUMENTS				
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author ( in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>	
JM	CA	Fujita et al., "Fabrication method of double micro lens array substrate," Japan Society of Applied Physics.		
JM	CB	Okada et al., "31a-W-11 Fabrication of double micro lens arrays using a self-alignment exposure method," Japan Society for Precision Engineering.		
JM	CC	Kitamura et al., "Fabrication Method of Double Micro Lens Array Using Self-Alignment Technology," 9th Microoptics Conference (MOC '03) Tokyo, October 29-31, 2003, pp. 114-17.		
JM	CD	Kitamura et al., "Fabrication Method of Double-Microlens Array Using Self-Alignment Technology," Japanese Journal of Applied Physics, Vol. 43, No. 8B, 2004.		

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>1</sup> Applicant's unique citation designation number (optional). <sup>2</sup> Applicant is to place a check mark here if English language Translation is attached.

Examiner Signature	/John McPherson/	Date Considered	01/19/2007
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